



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Inventor: David Russell Evans

Serial No.: 09/270,606

Filed: March 17, 1999

Title: METHOD FOR
MODIFICATION OF
POLISHING
PATTERN
DEPENDENCE IN
CHEMICAL
MECHANICAL
POLISHING

PATENT APPLICATION

Attorney Docket No.
SLA 587 (SMT 335)

Group No. 1765

Examiner: M. Anderson

Box Fee Amendment
Assistant Commissioner for Patents
Washington, DC 20231

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

This Response is an amendment responsive to an Office
Action dated July 13, 2001.

Please amend the above-identified application as follows: